

PATENT

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: TRAVIS A. LEMKE	Anticipated Examiner: Walker, W.
Serial No.: to be assigned	Anticipated Group Art Unit: 1723
Filed: herewith	
For: CONDUCTIVITY FEEDBACK CONTROL PROCESSES FOR SLURRY BLENDING	Docket No. 54197-237098

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Commissioner for Patents
Washington, D.C. 20231

CERTIFY THAT, ON JUNE 7, 2001, THIS PAPER IS BEING DEPOSITED WITH THE UNITED STATES POSTAL SERVICE AS EXPRESS MAIL, POST OFFICE TO ADDRESSEE SERVICE UNDER 37 C.F.R. 1.110 IN AN ENVELOPE ADDRESSED TO THE COMMISSIONER FOR PATENTS, WASHINGTON, D.C. 20231.

Simon Pilbrow

INFORMATION DISCLOSURE STATEMENT

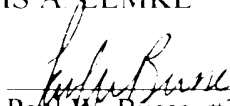
The documents listed on the enclosed Form PTO-1449 are presented pursuant to Applicant's duty of disclosure under 37 C.F.R. § 1.56. These references are of record in the related parent applications. Additional information is set forth in the "Background of the Invention" section of the application.

No fee is believed to be necessary for the entry of this Information Disclosure Statement. Should any fee be required, the Commissioner is authorized to charge our Deposit Account No. 06-0029 and notify us of the same.

Respectfully Submitted,

TRAVIS A. LEMKE

By:


Paul W. Busse, #32,403
Special Counsel
FAEGRE & BENSON LLP
2200 Wells Fargo Center
90 South Seventh Street
Minneapolis, MN 55402-3901
612/766-7046

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June 7, 2001
Page 1 of 2

Form PTO-1449 U.S. Department of Commerce
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INFORMATION DISCLOSURE
STATEMENT BY APPLICANT

Atty. Docket No. 54197-237098
Serial No. to be assigned
Applicant TRAVIS A. LEMKE
Filing Date Herewith
Group

#2
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U.S. PATENT DOCUMENTS

Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
TS	5,755,614	5/1998	Adams et al.			
TS	5,664,990	9/1997	Adams et al.			
TS	5,647,989	7/1997	Hayashi et al.	210	641	
TS	5,632,960	05/1997	Ferri, Jr. et al.	422	106	
TS	5,522,660	06/1996	O'Dougherty et al.	366	136	
TS	5,490,611	02/1996	Bernosky et al.	222	1	
TS	5,447,056	09/1995	Foote	73	61.71	
TS	5,364,510	11/1994	Carpio	204	153.1	
TS	5,340,370	8/1994	Cadien et al.			
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TS	5,272,027	12/1993	Dillenbeck et al.	430	30	

FOREIGN PATENT DOCUMENTS

Name	Document Number	Date	Country	Class	Subclass	Translation Yes/No
TS	62-11520	10.07.85	Japan			Yes, abstract only
TS	0 605 395	6 July 1994	EP			
TS	0 714 054	29 May 1996	EP			
TS						

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

TS	Philipossian, et al., "An Overview of Current Issues and Future Trends in CMP Consumables," Proceedings of the First CMP-MIC Conference, February 1996, pp. 13-19
TS	J. P. Bare, "Improved Analytical Technique for Metal CMPO Slurry," Proceedings of 2nd CMP-MIC Conference, February 1997, pp. 405-408
TS	Adams, et al., <i>CMP Slurry Reprocessing</i> , 6 pp.

Examiner T. Secher

Date Considered 11/14/02

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Sheet 1 of 3

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Filing Date

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Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
TS	4,977,929	12/1990	Chinnock et al			
TS	4,910,155	3/1990	Cote et al.			
TS	4,382,174	5/1983	Howard-Leicester			
TS	3,719,090	03/1973	Hathaway	73	432	
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FOREIGN PATENT DOCUMENTS

Name	Document Number	Date	Country	Class	Subclass	Translation Yes/No

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Examiner

T. Seemoo

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Sheet 2 of 3